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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Toshihide TSUBATA et al.	International Application No.:
Serial No.: Currently unknown	PCT/JP2004/018051
Filing or 371(c) Date: Concurrently herewith	International Filing Date:
Title: TRANSISTOR AND CVD APPARATUS USED TO DEPOSIT GATE INSULATING FILM THEREOF	December 3, 2004

**EXPRESS REQUEST TO BEGIN NATIONAL EXAMINATION PROCEDURES**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is an express request to begin national examination procedures under 35 U.S.C. § 371(f). As required by 35 U.S.C. § 371(c), this submission includes a copy of the International Application as filed, unless a copy of the International Application has already been communicated by the International Bureau; an English language translation of the International Application as filed; an oath or declaration of the inventor(s); and the national fee.

Respectfully submitted,

Dated: May 2, 2006

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